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APPLICATION NO.	FI	LING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.		
09/894,950	06/27/2001		Shunpei Yamazaki	07977/280001/US5027	6263		
26171	7590	10/12/2005		EXAM	EXAMINER		
FISH & RI P.O. BOX 1		ON P.C.	EVERHART	EVERHART, CARIDAD			
		55440-1022		ART UNIT	PAPER NUMBER		
	·			2891			

DATE MAILED: 10/12/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

			M
	Application No.	Applicant(s)	
	09/894,950	YAMAZAKI ET AL.	
Office Action Summary	Examiner	Art Unit	
	Caridad M. Everhart	2891	
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the	correspondence addre	SS
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION (36(a). In no event, however, may a reply be ting (ii) apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	N. mely filed the mailing date of this comm ED (35 U.S.C. § 133).	
Status			
1) Responsive to communication(s) filed on 2a) This action is FINAL . 2b) This 3) Since this application is in condition for allowar closed in accordance with the practice under E	action is non-final. noe except for formal matters, pro		erits is
Disposition of Claims			
4) Claim(s) 1-78 is/are pending in the application. 4a) Of the above claim(s) is/are withdray 5) Claim(s) 1-20, 33/are allowed. 6) Claim(s)	vn from consideration. 17, 70, 72, 74, 75, 78 18, 69, 71, 73, 76, 77		
Application Papers			
9) The specification is objected to by the Examine 10) The drawing(s) filed on is/are: a) access applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Examine 11.	epted or b) objected to by the drawing(s) be held in abeyance. Se ion is required if the drawing(s) is ob	e 37 CFR 1.85(a). ojected to. See 37 CFR	• •
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the prior application from the International Bureau * See the attached detailed Office action for a list	s have been received. s have been received in Applicat rity documents have been receiv ı (PCT Rule 17.2(a)).	ion No ed in this National St	age
Attachment(s)			
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 8-30-05;7-19-05.	4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal F 6) Other:		52)

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Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after allowance or after an Office action under *Ex Parte Quayle*, 25 USPQ 74, 453 O.G. 213 (Comm'r Pat. 1935). Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, prosecution in this application has been reopened pursuant to 37 CFR 1.114. Applicant's submission filed on 7-19-05 has been entered.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

The factual inquiries set forth in *Graham* v. *John Deere Co.*, 383 U.S. 1, 148 USPQ 459 (1966), that are applied for establishing a background for determining obviousness under 35 U.S.C. 103(a) are summarized as follows:

- 1. Determining the scope and contents of the prior art.
- 2. Ascertaining the differences between the prior art and the claims at issue.
- 3. Resolving the level of ordinary skill in the pertinent art.
- 4. Considering objective evidence present in the application indicating obviousness or nonobviousness.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein

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were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 1-10, 21-31, 47-54, 60,61,63,65,68,69,71,73,76, and 77 are rejected under 35 U.S.C. 103(a) as being unpatentable over Morita et al (US 6,259,200B1) in view of Sato et al (US 6,327,006B1).

Morita et al discloses a device which is formed o an insulating surface which is an insulating substrate (Abstract and col. 8, lines 17-18), a gate line and a shielding film formed on the surface(col. 8, lines 19-24 and col. 2, lines 27-33), in which the disclosure that the gate and shielding film are formed concurrently of the same material discloses that they are formed on the same surface. The shielding film has a planarization film over it(col. 4, lines 30-36) and and ITO film is over the planarization film(col. 4, lines 33-37), and this satisfies that there is a semiconductor film over the planarization film, as ITO is a semiconductor. The thickness of the shielding film and of the gate is 100nm, which is 0.1 micron(col. 6, lines 37-40). In Fig. 6 it is seen that the gate and shielding film are tapered. With respect to the limitation of a capacitance wiring, the lower metal of the gate line and the shielding layer can be considered the bottom capacitance wiring and the ITO layer can be considered that top capacitance wiring.

Morita et al is silent with respect to polishing or CMP being the planarization method of the planarization layer nor the recited devices.

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Sato, et al disclose a planarized layer between the TFT and the upper ITO layer which is planarized by CMP(layer 100 shown in Fig. 3 and described in col. 3, lines 3-15).

It would have been obvious to one of ordinary skill in the art at the time of the invention to have planarized the planarizing film in the process taught by Morita et al by using polishing or CMP because Sato et al teaches that the film in a similar device and because CMP is well known in the art. In addition, in the device claims it is the device which is rejected, and the method of planarization is not given patentable weight in a device claim.

It would have been obvious to one of ordinary skill in the art at the time of the invention to have used the device taught by Morita et al in the recited devices because it is well known in the art that the recited devices include TFTs, and Morita et al teaches TFTs.

Allowable Subject Matter

Claims 11-20, 32-46, 55-59,62,64,66,67,70,72,74,75, and 78 are allowable.

The prior art of record does not teach the TFT on the planarized layer in combination with the other limitations of the allowable claims.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Caridad M. Everhart whose telephone number is 571-272-1892. The examiner can normally be reached on Monday through Fridays 7:30-4:00.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, B. Baumeister can be reached on 571-272-1722. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

MAD EVERHART

C. Everhart 10-6-2005